

PTO-1449 Information Disclosure Citation in an Application	Application No.	Applicant(s)	
	10/678,837	Tomblad et al.	
	Docket Number 068736.0231	Group Art Unit 2811	Filing Date October 3, 2003

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MAY 09 2005

U.S. PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A.	5132753	7/21/92	Chang et al.	257	257	3/23/90
B.	6613622	9/2/03	Nair et al.	438	188	7/15/02
C.						
D.						
E.						
F.						
G.						
H.						
I.						
J.						
K.						
L.						
M.						
N.						
O.						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
P.						
Q.						
R.						
S.						
T.						
U.						

NON-PATENT DOCUMENTS - DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

V.	Dragon et al., "A Silicon MOS Process for Integrated RF Power Amplifiers," IEEE MTT-S Digest, Pages 257-260	6/17/96
W.		
X.		
Y.		
Z.		

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.